Supporting Information

Acid-Induced Mixed Electron and Proton Conduction in Thin ZrO₂ Films

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EXPERIMENTAL METHODS

Bis(2,2'-bipyridine)(4,4'-diphosphonato-2,2'-bipyridine)ruthenium(II) bromide (Ru(II)phos) was prepared as previously described.¹

Sample Preparation. ZrO_2 films were fabricated using a Cambridge Savannah 200 ALD system. Vapor pulses were held in the reaction chamber for 3 minutes followed by opening the valve and purging with N_2 for 25 seconds before the next pulse. Tetrakis(dimethylamido)zirconium was used as a precursor with a deposition temperature of 200 °C and a precursor temperature of 75 °C. The pulse durations for this material were 0.015 s and 0.25 s for the water vapor and ZrO_2 precursor, respectively. The deposition rate for this precursor is commercially reported to be 1.02 Å per cycle at 200 °C on a Si wafer, which agrees well with our ellipsometric measurements on a silicon wafer. Films ranging from 0 to 40 Å were grown on mesoporous, nanoparticulate SnO_2 and from 0 to 200 Å on planar sapphire substrates. ALD is a well-established technique for growing conformal, pinhole-free layers on mesoporous substrates. Following shell deposition, all films were annealed at 450 °C for 30 min. Dye-sensitized samples were sensitized in the dark from a 100 μ M solution of Ru(II)phos in anhydrous ethanol for 16 hours.

The preparation of high surface area, nanoparticulate SnO_2 films on fused quartz substrates for time-resolved THz spectroscopy (TRTS) measurements are described in detail elsewhere.⁴ Briefly, the films were prepared by doctor-blading a SnO_2 paste on fused quartz substrates using Scotch Magic tape as a spacer layer and then sintering at 470 °C. Samples for TRTS were sealed using a second piece of fused quartz separated with a 60 μ m Surlyn (Solaronix) spacer between the two pieces of quartz and filled with 0.1 M $HCIO_4$ (aq) or 0.1 M $LiCIO_4$ in acetonitrile, as described in the text.

Scanning/transmission electron microscopy and energy-dispersive X-ray spectroscopy was carried out on an FEI Talos F200X S/TEM instrument. XPS was carried out on a PHI *VersaProbe* II Scanning XPS Microprobe.

Conductivity Measurements. Gold electrical top contacts with a chromium adhesion layer were deposited onto 4 and 20 nm ZrO_2 films on sapphire by physical vapor deposition (Figure S1). The conductivity was obtained from current-voltage characteristics in the range of 0 to 10 V with an Agilent B1500A semiconductor device analyzer equipped with medium-power source-measurement units that use atto-sense and switch units for high-resolution current sensing. Samples were mounted on a triaxially grounded sample stage inside a vacuum chamber. Humid atmosphere conditions were achieved by saturating the vent valve screen attached to the inlet port of the vacuum pump with either water or D_2O ($p_{H2O} = 0.012 \pm 0.003$ atm) just prior to venting the system with ambient air ($p_{H2O} \sim 0.007$ atm). Acid-treated samples were soaked after electrode deposition for a minimum of 8 hours in 0.1 M HClO₄ prior to electrical measurements.

TRTS Measurements. Specific details for OPTP measurements are described in detail elsewhere. $^{5-6}$ OPTP scans are obtained by measuring the change in THz pule amplitude (Δ THz) resulting from photoexcitation with 400 nm light as a function of optical-pump THz-probe time delay.

The TRTS scans were fit using the following function:

$$\Delta THz = -\left\{ \sum_{i=1}^{n} A_{i} \left[\exp\left(-\frac{t - t_{0}}{\tau_{i}}\right) - 1 \right] \right\} \otimes G\left(FWHM\right)$$
(S1)

where n is the number of exponentials included in the fit, t_0 corresponds to arrival time of the photoexcitation pulse (i.e., t=0), A_i is the amplitude of a given component, τ_i is the lifetime of a given component, G(FWHM) is a Gaussian instrument response function with a full-width at half-maximum of 0.5 ps, and \ddot{a}_{-n} represents a convolution.

Quantum chemistry calculations. Density functional theory (DFT) calculations using the Gaussian09⁷ software at the B3LYP/Def2TZVP//Def2SVP⁸ level of theory were performed on the ester form of Ru(II)Phos in implicit CH₃CN,⁹ and the acid form in H₂O, respectively. The ground state, S₀, first triplet excited state, T₁, and singly oxidized state, were optimized with unrestricted DFT (uDFT) with the Def2SVP basis set.¹⁰ The first excited singlet state, S₁, was optimized with linear-response time-dependent (TD) DFT with the Def2SVP basis set. At each of the four resulting geometries (optimized S₀, S₁, T₁, and Ox. geometries), single point energy calculations were performed for all electronic configurations, yielding in total 16 points on four potential energy surfaces (PES). The single point calculations were done with the Def2TZVP basis set except for S₁ where the Def2SVP basis set was used. The experimental oxidation potential was obtained from voltammetry measurements of the esterified form of Ru(II)phos in a CH₃CN solvent, so corresponding calculations in the same solvent were performed on the ground and oxidized states at the same level of theory. Calculated potentials vs NHE were obtained by assuming an NHE potential of 4.44 V vs vacuum.¹¹

The electron transmission T(E) through the ZrO₂ was modeled with the WKB approximation:

$$T(E) = e^{-2\int_0^1 \sqrt{\frac{2m|E - \xi(x)|}{h^2}} dx} = e^{-2d\sqrt{\frac{2m|E - \xi|}{h^2}}}$$
(S2)

with barrier widths d and electron mass m, ξ is taken as the excited state potential of Ru(II)Phos and E as the CBM of ZrO₂.

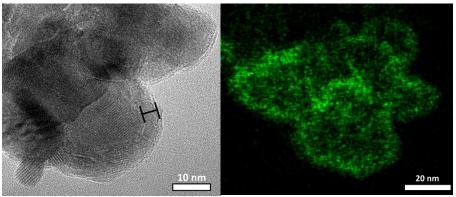


Figure S1. (*Left*) High resolution TEM image of particles from a SnO₂/40p ZrO₂ (~40 Å) nanoparticle film after use in TRTS experiments. Brackets identify ZrO₂ film on the SnO₂ core (*Right*) Representative energy dispersive X-ray spectroscopy map image of 40 pulse cycles (~40 Å) of ZrO₂ coated on SnO₂ nanoparticles (collected after TRTS measurements). Zr is colored green and is seen to uniformly coat the SnO₂ particles.

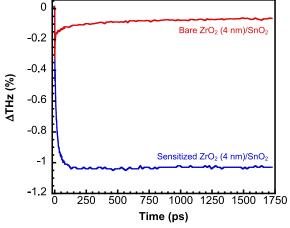


Figure S2. TRTS electron injection for Ru(II)phos-sensitized and bare SnO₂ covered with a 40 Å ZrO₂ film sealed in 0.1 M HClO₄.

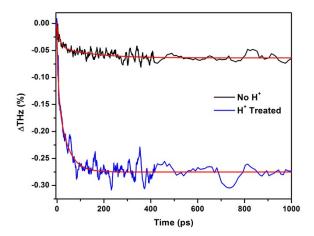


Figure S3: TRTS electron injection for Ru(II) phos-sensitized $ZrO_2(40 \text{ Å})/SnO_2$, measured in acetonitrile with 0.1 M $LiClO_4$. The H^+ -treated sample was exposed to 0.1 M $HClO_4$ overnight, rinsed with water and dried before being sealed with the acetonitrile solution.

Table S1. Fitting Parameters for SnO₂/ZrO₂ core/shell structures from Figure 3a.

Shell Thickness [Å]	A ₁ [%]	$ \tau_1 $ [ps]	A ₂ [%]	τ ₂ [ps]	A ₃ (%)	τ ₃ [ps]	$egin{array}{c} A_4 \ [\%] \end{array}$	τ ₄ [ps]	scaling factor	$<\tau_{\rm w}>$ [ps]
0	0.20	1.1	0.58	7.5	0.22	38	-0.55	9644	1.32	17
1.02	0.36	2.8	0.52	12	0.12	67			1.45	16
2.04	0.39	2.8	0.49	15	0.12	103			1.62	21
2.04	0.39	2.7	0.49	14	0.12	107			1.67	20
5.10	0.38	2.8	0.46	17	0.16	101			1.16	25
5.10	0.42	3.2	0.46	16	0.11	106			1.21	21
10.2	0.38	3.1	0.47	17	0.15	127			0.90	28
10.2	0.61	5.2	0.24	24	0.16	277			0.71	52
20.4	0.30	2.8	0.54	14	0.16	111			0.70	26
20.4	0.45	3.6	0.44	16	0.12	98			0.68	20
40.8	0.32	2.8	0.50	20	0.18	227			0.62	52
40.8	0.26	2.4	0.47	18	0.27	209			0.42	66

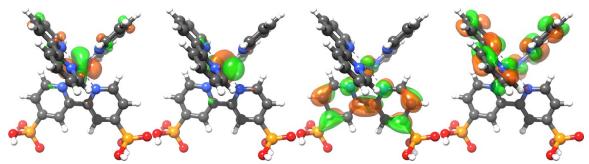


Figure S4. Isodensity plots (isovalue=0.035) of HOMO-1, HOMO, LUMO, and LUMO+1 of the Ru(II)phos dye in its ground state, as calculated at the B3LYP/Def2TZVP//Def2SVP level of theory in a water implicit solvent.

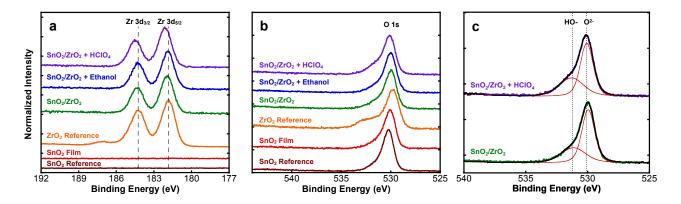


Figure S5. a) Zr 3*d* and b) O 1*s* X-ray photoelectron spectra of commercial SnO₂ and ZrO₂ powders, an SnO₂ film made from the commercial powder, as-prepared SnO₂/ZrO₂ (40 Å) film, and SnO₂/ZrO₂ (40 Å) films that had been exposed to either ethanol or 0.1 M HClO₄ overnight. All film samples were mechanically scraped up into a powder for analysis. c) Constrained fitting of the O 1*s* spectra for as-prepared SnO₂/ZrO₂ and acid-treated SnO₂/ZrO₂. The acid treated sample exhibits an increased ratio of hydroxyl oxygen to bridging oxygen (0.7:1) as compared to the as-prepared material (0.52:1).

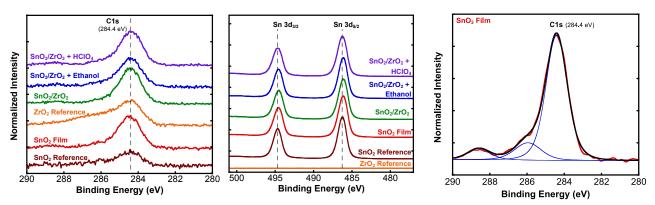


Figure S6. (*Left*) C 1s and (*middle*) Sn 3d X-ray photoelectron spectra of commercial SnO₂ and ZrO₂ powders, an SnO₂ film made from the commercial powder, as-prepared SnO₂/ZrO₂ (40 Å) film, and SnO₂/ZrO₂ (40 Å) films that had been exposed to either ethanol or 0.1 M HClO₄ overnight. All film samples were mechanically scraped from the quartz substrates into a powder for analysis. (*Right*) Experimental XPS spectrum of SnO₂ film (red) and XPS spectrum (black) generated from a fit with three components (blue) to show features at 284.4, 286, and 288.5 eV.

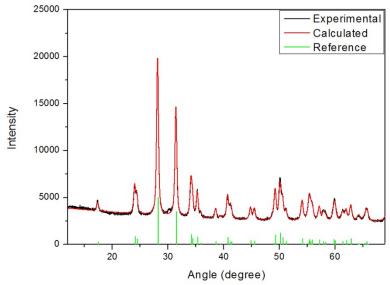


Figure S7. X-ray diffraction pattern for ZrO₂ reference powder (black, experimental) with Rietveld refinement (red) of the monoclinic ZrO₂ reference pattern (green, JCPDS 98-000-0105).¹²

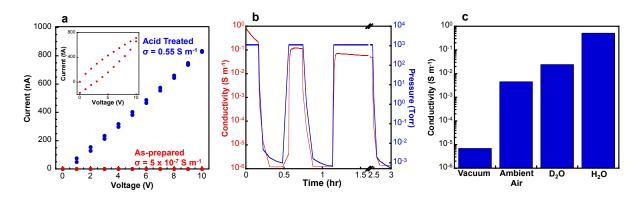


Figure S8. a) Current versus applied potential (I–V) for 40 Å ZrO_2 films on sapphire patterned with interdigitated gold electrodes. Acid-treated film soaked in 0.1 M $HClO_4$ (aq) for 18 hours. (*Inset*) The I–V curve for as-prepared ZrO_2 . b) Conductivity of an acid-treated 40 Å ZrO_2 film as a function of pressure in ambient atmosphere. c) Conductivity of an acid-treated 40 Å ZrO_2 film in vacuum, ambient air, D_2O_2 humidified air, and D_2O_2 humidified air.

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